



IBIC 2012

ELECTRON-LENS TEST STAND INSTRUMENTATION PROGRESS

T. A. Miller⁺, J. Aronson, D. M. Gassner , X. Gu, A. Pikin, P. Thieberger, C-AD, BNL, Upton, NY, 11973, U.S.A.



1

THCB01



Toby Miller



Partial head-on beam-beam compensation with one E-Lens per ring.



beam-beam interaction

Basic idea:

 2 beam-beam collisions with positively charged beam

 Add collision with a negatively charged beam – with matched intensity and same amplitude dependence

Resulting effects:

- Increased beam lifetime
- Increased luminosity

Built on experience with:

Tevatron electron lens

A. Burov, V. Kamerdzhiev, V. Shiltsev, G. Stancari, A. Valishev, X.-L. Zhang...





Toby Miller

2



Electron Lens Test Bench Overview



- Purpose

- Test Electron Gun, Water cooled Collector, modulator, and instrumentation for the E-Lens Project
- System Specs:
 - Beam Energy: 5keV
 - Beam current: 0.6A nominal (1.0A test)
 - Modulated electron gun: 0.5us DC
 - Rep. rate: 1Hz, 10Hz, 100Hz, 80kHz



p+

Current Transformers

CTs at Gun and Collector: (1 - 5µs / 100µs – DC)

Toby Miller

- DCCT: Bergoz IPCT, 1 2000mA (1µA res.), DC 100µs
- Pulse CT: Pearson 6585, 1V/A, 50Ω, 0.3%/µs droop
- Calibrator: 0-0.5A @ DC/0.1-1000µs
- CT at CPS Ground
 - Pearson 6585

Static Magnetic Fields

- Gun Solenoid
- Central Super Cond. Solenoid
- Collector Solenoid
- 100 Gauss line (pink) : E-Lens















4



Ground Coupling Problem





Ringing in pulsed current meas.



- CTs installed on beam power supply conductors
 - Mismatched power transmission line
 - No space for in-vacuum beam current CT
- Main HV power transport: parallel conductors in separate conduit
 - Changed to RG213 coax → Same Ringing
- RC installed on ends of 50 Ω power cable \rightarrow no change
- Capacitor added across ceramic break $\rightarrow \Delta f_{\rm C}$ only; same amplitude









Static Magnetic Field Interference on DCCT



- Static Field measured = ~15 Gauss (collector)
 - ~36 Gauss expected in E-Lens
 - Field varies ± with Oper'g param's
- DC offset
 - 150mV offset with ~15 Gauss field
 - 0.030" MuMetal Shield -> 1 Gauss
 - Iron + MuMetal design underway

Toby Miller

AC oscillation



IBIC 2012

- 7kHz internal excitation seen on output when in field (pink)
- Within spec (25mV) with shield (accuracy preserved)



7

YAG Beam Profile Monitor



System Overview



- Camera: Manta G145B, GigE, 2/3" CCD 1.5MP 12-bit
- Zoom Lens: manual
- Target: YAG:Ce single crystal (20mm active area X 0.1mm thick) distance = 1.3m from lens
 - Crystals coated with either 100nm Al or C coatings applied at BNL for bleeding off charge
- Illumination:
 - Adjacent mounted White projection LED
 - Adjacent mounted 455nm (blue) projection LED
 - On Axis 405nm (violet) Laser via dichroic beam splitter



8





Lens Comparison



IBIC 2012

Performance Details

Toby Miller



9



Adjacent mounted Illumination

Toby Miller



IBIC 2012

IBIC 12

Beam of Light

THCB01

- Stimulate YAG:Ce to fluoresce
 - 455nm Royal Blue collimated LED
 - 405nm Violet Laser module



10



UV Filter Selection



Use UV filter to block unwanted UV from affecting camera



Energy Absorbed in the filter ! →Local emission Longpass colored glass filter, Thorlabs FGL435S

"Wrong choice!"



All Energy Reflected →NO emission!

Longpass dielectric coated filter, Thorlabs FEL0500 "Edgepass"















On Axis Laser Illumination

- Propagate 405nm laser through camera lens
 - On axis— easier to close gap around lens on viewport
 - Magnified laser spot
- Use dichroic Beam Splitter (BS)
 - Reflect Blue & Violet
 - Pass YAG emission



Toby Miller



- 3mm thick optic: grossly out of focus
- 1.1mm thick optic: 34µm resolution







YAG Beam Profile Measurements

- Image analysis tools
 - Define 20mm Ref. Circle

using white light illumination allowing calibration of beam size

- Find Center of Gravity allows calibration of beam size
- Define Arbitrary 3rd Axis
 - 45° in example shown
- Generate profiles along axes.
- Calculate parameters:
 - Sigma
 - Gaussian fit (χ²)
 - Beam size
 (based on x% threshold; where x is user defined)





Toby Miller

13



YAG Damage Incident

- 3 shots of 80µs pulse of 400~500mA beam, 5keV
 - Based on pre-commissioned diagnostics & data loggers
- Result :
 - → Thermal damage to the crystal
 - Partially still fluorescent during bench inspection
 - Color photo of UV illumination shows blue reflecting area and yellow fluorescent area
 - aluminum holder shielded 5mm ring around crystal



YAG Heating Model

Approximate penetration thicknesses for a 5 keV electron beam incident on a YAG screen covered with a 100 nm thick aluminum layer

5 keV electrons



The entire energy is deposited in a surface layer only about 0.2 microns thick leading to potential thermal shock damage due to sheer stresses that develop due to differential expansion of adjacent layers that are at different temperatures. Ranges are rough estimates based on the so called corrected Gruen formula.







YAG Heating Model

Temperatures at the center of a 1cm diameter (6 σ), 200 mA, 5 keV, 1 μ s long electron beam on a YAG screen with 0.1 μ m thick aluminum



Destructive YAG Test

p⁺ (p⁺)

IBIC 2012

- Before replacing YAG, the damaging beam pulses were repeated & documented
 - 660mA pulses, 80µs long, 1Hz repetition rate

Toby Miller

- YAG heated so much that deflection was visible after each shot
- Couldn't reproduce the same level of damage with the expected parameters... WHY?



17

See this video on line at: http://www.youtube.com/watch?v=TOrgEd4AAAI/...



YAG Damage Analysis



- Color: white opaque
- Surface: still smooth -
- Micro damage points seen under microscope

Damaged YAG in aluminum holder (downstream side)

















Four Quadrant Halo Monitor

- Located with YAG & Pinhole just before collector
- Unbiased, 33.5mm aperture
- Integrated signals logged from isolated electrodes
- Waveforms:
 - 1) Pulsed beam image current induced on halo electrodes. Room to scan without loss.

Toby Miller

- Signature of beam oscillating between gun and collector → V_{CPS} too low.
- 3) Direct hit by beam

V_{CPS}=Collector Power Supply

Conceptual Design

NATIONAL LABORATOR

Opened during YAG replacement

19





Installation of two E-Lens machines in RHIC planned over the next several months.

Remaining tasks to complete:

- 1) Complete commissioning of a Pinhole-Scan Profile Monitor
 - a) Compare to YAG profiles
- 2) Solve pulse ringing problem current transformers
- 3) Perform controlled destructive YAG test
 - a) Find operational thermal limit
 - b) Find permanent thermal limit
- 4) Test new BPM design & commission electronics







I would like to thank following colleagues for their support:

- K. Hamdi, J. Hock,, C.Liu, B. Sheehey, M. Stetski and other members of the Collider-Accelerator Department
- B. Schoepfer and members of the EBIS group
- Z. Altinbus, A. Fernando, L. Hoff, R. Olsen, C. Theisen, and members of the controls group.
- N. Baer, J. Carlson, T. Curcio, S. Jao, J. Kelly , B. Johnson, K. Mernick, and other members of the Accelerator Instrumentation and Beam Components Group

Thank you for your attention



